# E-TEST : Einstein Telescope EMR Site and Technology

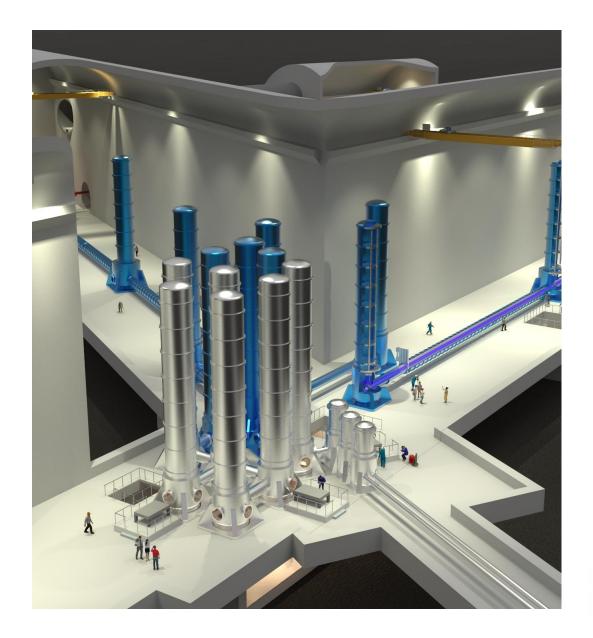
Dr. Chiara Di Fronzo

On behalf of Prof. Christophe Collette









### **E-TEST objectives**

- Large mirror (100 Kg)
- Cryogenic temperature (10-20 K)
- Isolated at low frequency (0.1-10 Hz)
- Compact suspension (4.5 meters)

### **E-TEST feasibility strategy**

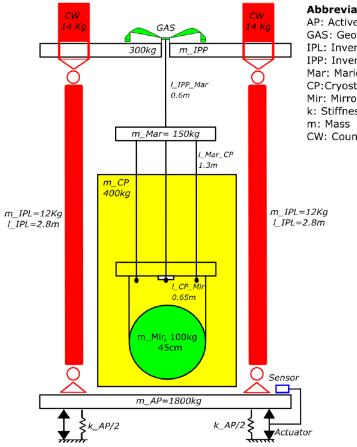
E-TEST is a project funded by the Interreg Euregio Meuse-Rhine and ET2SME consortium, which allow us to capitalize on <u>existing infrastructure</u> at Centre Spatial Liège (CSL) for the construction of the facility.







#### **Prototype E-TEST**



#### Hybrid (active + passive) isolation Radiative cooling

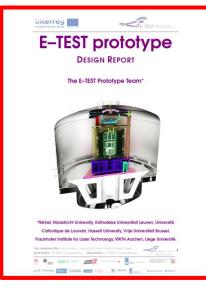
#### Abbreviation:

AP: Active Inertial Platform GAS: Geometric Anti-Spring IPL: Inverted Pendulum Leg IPP: Inverted Pendulum Platform Mar: Marionette CP:Cryostat+Cold Platform Mir: Mirror k: Stiffness CW: Counter Weight









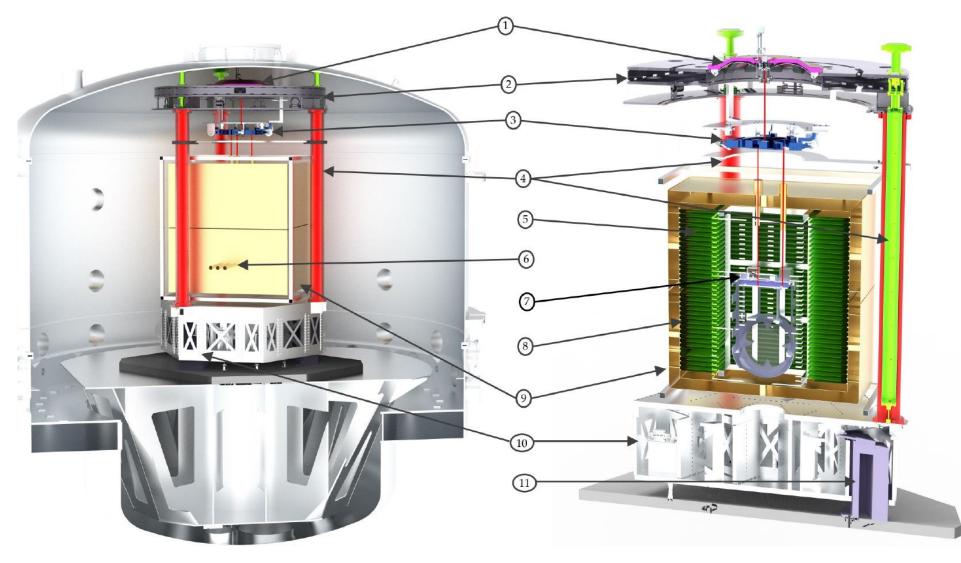
#### Vibration isolator

 1) GAS filter
 2) Inverted Pendulum (IP) platform
 3) Marionette
 4) IP legs
 10) Active platform

#### **Cryogenic payload**

5) Heat exchanger and cold platform7) 25K inner thermal shield8) 80K outer thermal shield

#### Submitted: 12/2021 Revised: 03/2022

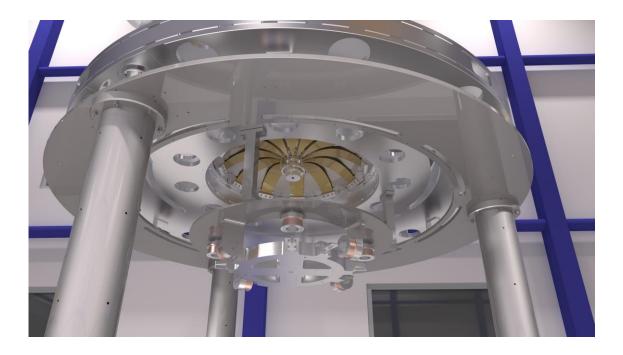






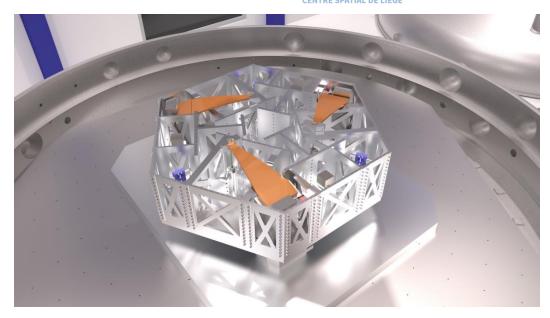
### **Mechanical design state-of-the-art**

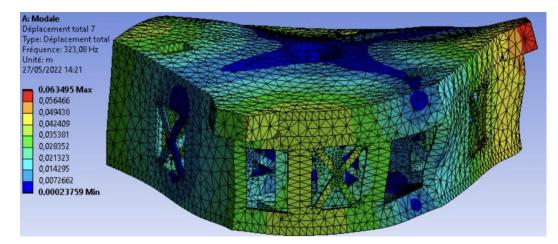
- Production drawings of the whole prototype finished!
- All mechanical parts in production
- Start assembly in May 2023



Contact: Ameer Sider (PML) asider@uliege.be



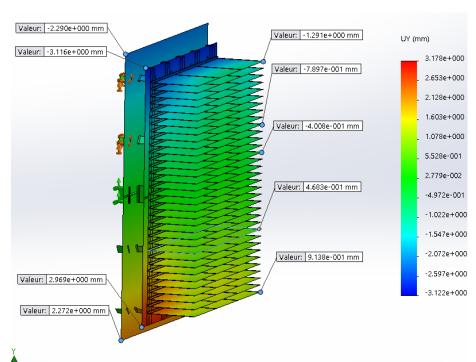


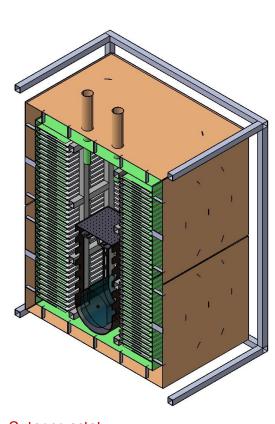




### **Cryostat development**

- ✓ overall dimensions:  $1.8 \times 1.6 \times 2 \text{ m}^3$
- ✓ conventional radiator design with horizontal fins (25K)
- ✓ three 30-mm diameter optical feedthroughs towards the mirror





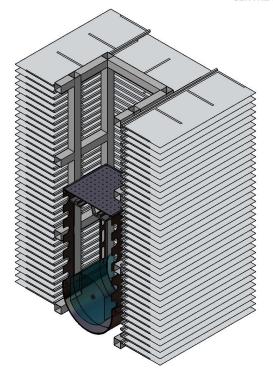
#### Outer cryostat

(connected to the vacuum chamber):

- 80K LN2 shield (brown)
- 25K GHe panels (green)

# radiation heat transfer for mirror cooling





Inner cryostat suspended and conductively linked to the silicon mirror

Contact: Cedric Lenaerts (CSL) Cedric.Lenaerts@uliege.be

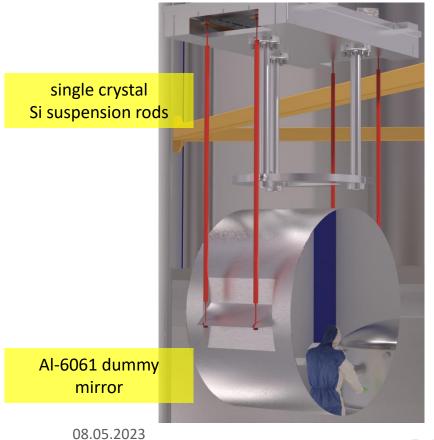


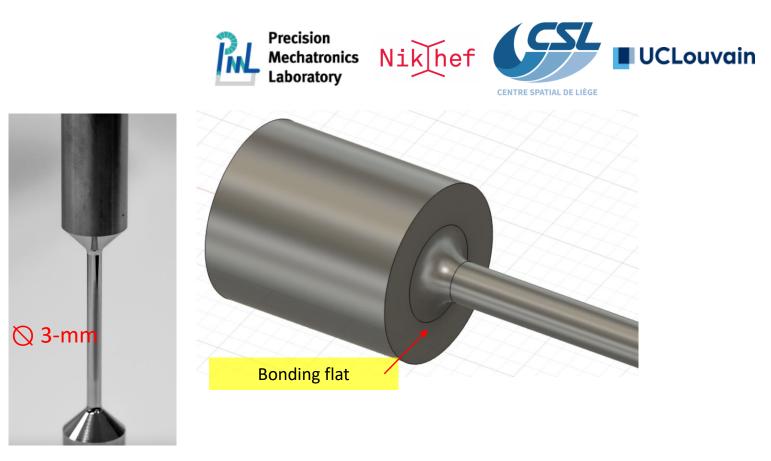


## **Ultra-cold vibration control**

Crystalline silicon mirror suspension

- Crucial technology aspect for ET: no proven solution exists
- Four machined samples delivered





- All samples, including the new ones with bonding flats, sent to Università di Perugia for mechanical loss vs T and tensile strength measurements
- ET2SME partners Mat-Tech (NL) and MaTecK (D) will do R&D on Si-metal interfaces



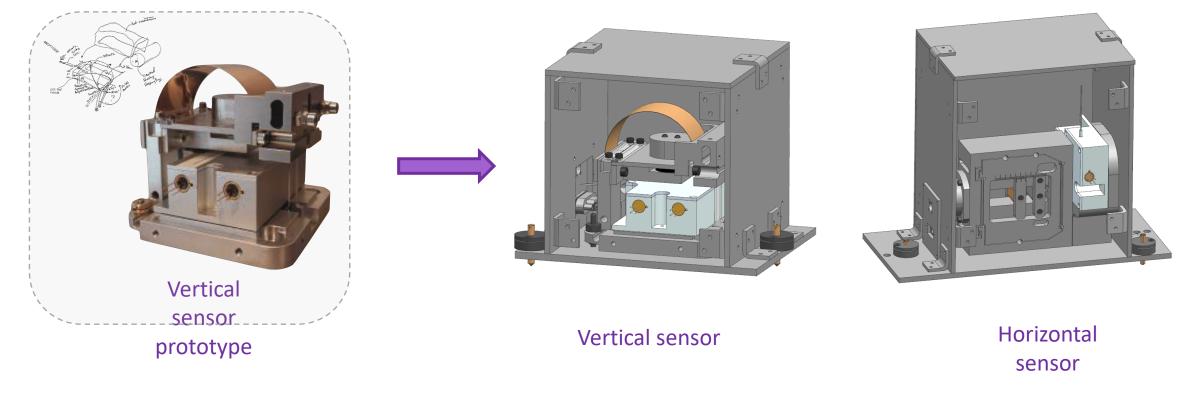


Contact: Alessandro Bertolini (Nikhef) alberto@nikhef.nl

### **Ultra-cold vibration control**

Inertial sensors development for active seismic attenuation at low frequency

- Laboratory prototype is getting turned into its final design
- Production drawings in progress; manufacturing starting in the coming weeks



Anthony Amorosi (PML) Anthony.Amorosi@uliege.be Loïc Amez-Droz (PML) lamezdroz@uliege.be





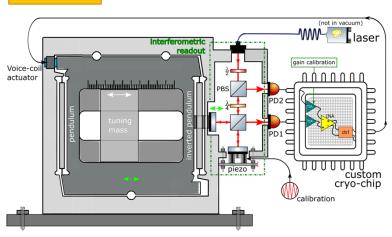


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### **Ultra-cold vibration control**

#### Cryogenic inertial sensors

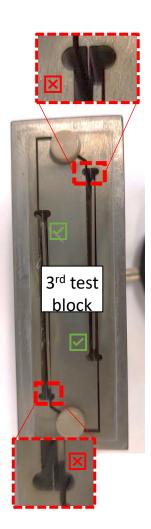
CSIS-H



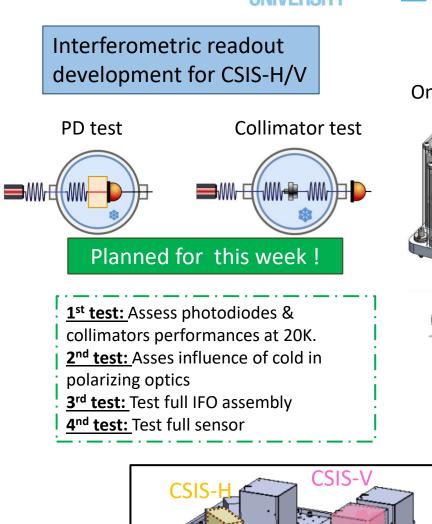
<u>Mechanics</u>: new manufacturing test of the flexures in niobium failed. We may change titanium alloy (TiAl6V4) if still not working.

Actuator: while superconducting coil actuator development is ongoing, switch to shielding-magnet voice-coil actuators to avoid eddy-current damping.

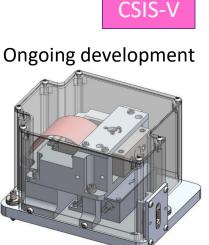
Morgane Zeoli (PML) morgane.zeoli@uliege.be

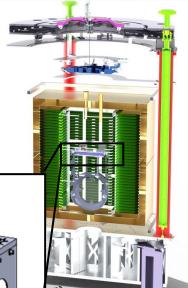






### UCLouvain





Euregio Meuse-Rhine European Regional Development Fund

#### **Cryogenic test bench**

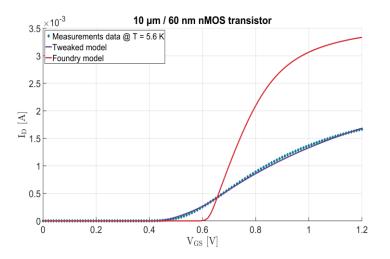


- Closed-cycle cryostat providing up to 1W cooling power at 10K
- Vacuum level: better than 10<sup>-9</sup> mbar
- Usable volume: cylindrical 15x15cm
- Fast turnaround and low running costs
- Useful for testing materials, components and assemblies





# Custom CMOS chips for sensor signal conditioning at low temperature



- Major achievement in cryogenic CMOS structures modeling: faithful representation over the full range of gate-channel geometries
- Custom Au-plated parts for photodiode test setup received

FOUNDRY MODEL Error\* up to 65 % OUR CRYO-MODEL (SO FAR) Error\* < 5.7 %

\*Maximum current error in saturation and linear region of operation

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### **Silicon Mirror Coating**

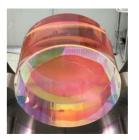
• State of the art:

Noise of amorphous coatings are the main performance limitation for GW telescopes, especially the thermal noise

- ETEST approach: single-crystal oxide mirror coatings
- Current activities
  - Setup of Cr<sub>2</sub>O<sub>3</sub> thin film thickness set
  - More data expected next time

#### First tests:

- Cryogenic measurements of crystalline substrates ٠
  - Analysis of mechanical loss with respect to the ٠ temperature
    - Different lines correspond to different wave modes
- Preliminary result: Minimum of the loss angle at 40 K ٠
  - Origin yet unknown, further analysis will follow ٠
- Next step ٠
  - Deposit Cr2O3 thin film on the characterized ٠ substrates and measure new combination



0.000

1×10<sup>-5</sup>

1×10<sup>-6</sup>

1×10<sup>-1</sup>

1×10

15 30 45 60 75

Loss angle

#### Mechanical losses

- Coating: 500 nm Cr<sub>2</sub>O<sub>3</sub>/Al<sub>2</sub>O<sub>3</sub> 5 x 10-6 1E-04 1E-05 1E-06 ----- resonator ---- coating L. Mereni et al. 1E-07 1E-08 mode (0,3 1E-09 Temperature [K]
- Dilution factor= 0.0034 Assumptions:

(0,2) -----

(0,3) —×

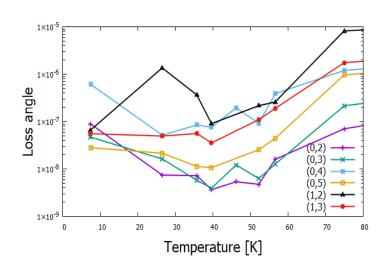
(0,4)

(0.5)

(1,2)

90 105 120 135 150 165 180 195 210 225 240 255 270 285 300

European Regional Development Fund





Einstein Telescope

**Contact: Jean-Pierre Locquet** jeanpierre.locquet@kuleuven.be

 $d_{\text{coating}} = 500 \text{ nm}$ 

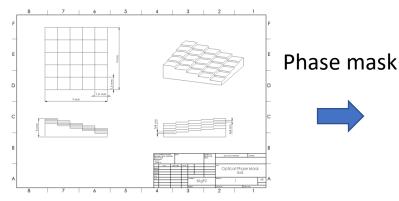
 $d_{substrate} = 0.3 \text{ mm}$ 

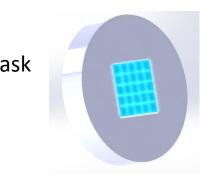
Y<sub>coating</sub> = 260 GPa Y<sub>substrate</sub> = 385 GPa **KU LEUVEN** 



### Silicon Mirror Manufacturing & Test

- Experiment purpose
  - Characterization of the cryogenic mirrors for GW detectors on operation
- Added value
  - Measurement of local values of vibration and topology change instead of a single absolute value of the full mirror
- Current tasks
  - Optical design development
  - Custom optical phase mask arrived and experiments on proof of concept are being performed







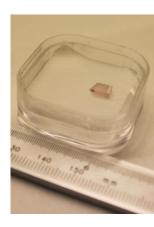
Contact: Jesus Vilaboa Perez (CSL) jvilaboaperez@uliege.be





#### **Laser Development**

- Requirements:
  - High stability, Narrow linewidth
  - Wavelength: 2090 nm, Power: 5-10 W
- Approach:
  - Solid state laser seed source (Ring-Oscillator / Non-Planar Ring-Oscillator)
  - Two-stage holmium-doped fiber amplifier
  - Internal stabilization mechanisms
- Current activities
  - Setup of final stages and power stabilization







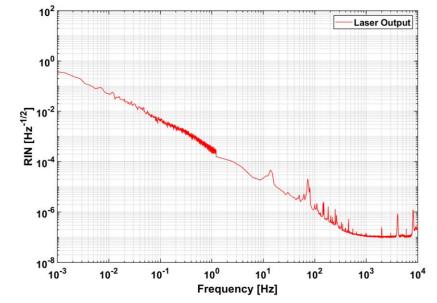








- Status: Most fiber laser requirements successfully demonstrated
  - Output power, spectrum, polarization, ...
  - Current analysis: Relative Intensity Noise (RIN)
- Holmium-amplifier (Ho1) preliminary results without stabilization
  - Low frequencies: High RIN expected
     → No thermal stabilization
  - Mid frequencies: <u>Good results without stabilization</u>
     → RIN @ 100 Hz is app. 10<sup>-6</sup> 1/VHz
     → Already very close to the project goals
- Next steps: Active power stabilization and further improvement of setup





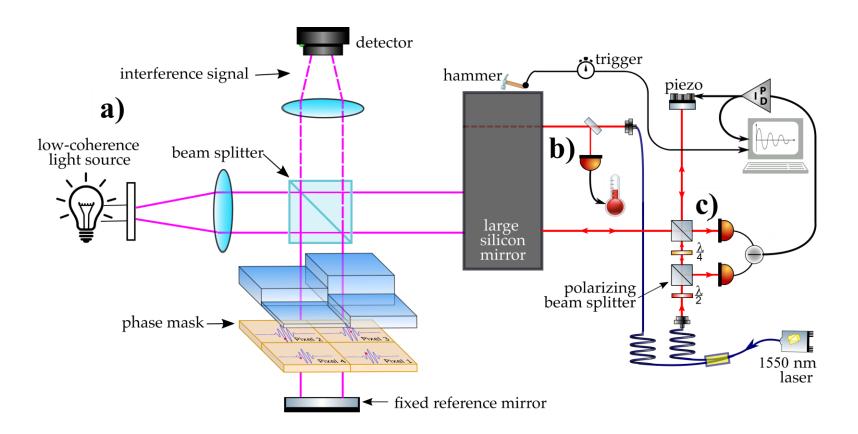
### Final validation of the prototype

- a) White lightinterferometry(residual stress)
- b) Temperature measurement
- c) Quality factor

Tests at CSL timeline:

2023: with dummy Al mirror

2024: with 100kg Si mirror









#### **Contacts:**

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#### **Useful links:**

#### TDR

https://arxiv.org/abs/2212.10083 **E-TEST Project website** https://www.etest-emr.eu/ **PML website** http://www.pmlab.be/



